

PATENT APPLICATION

Atty. Docket No.: 2522-033

Serial No. not yet assigned

Applicant: Eung-Joon LEE, In-Sun PARK and Ji-Soon PARK

Filing Date: July 29, 2003

Group: not yet assigned

For: METHOD FOR FORMING SILICIDE FILM OF A SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE CITATION
FORM PTO-1449 (Modified)

U.S. PATENT DOCUMENTS

Exam Init	Ref	Document Number	Issue Date	Name	Class	Sub Class
_____	_____	6,303,503B1	10/16/2001	Kamal et al.		

FOREIGN PATENT DOCUMENTS

Exam Init	Ref	Document Number	Publication Date	Country	Name
_____	_____				

OTHER DOCUMENTS

Exam Init	Ref	Author, Title, Date, Pertinent Pages, Etc.)
_____	_____	

Examiner: Asde Munar Sarhan

Date Considered: May 11, 2004